Search Notes						

Application/Control No.	Applicant(s)/Patent under Reexamination
10/536,456	OKADO, HIRONORI
Examiner	Art Unit
Shih-Chao Chen	2821

SEARCHED					
Class	Subclass	Date	Examiner		
343	700MS, 767, 846	10/1/2006	CHEN		
<u>-</u>					
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
700MS	10/1/2006	CHEN		
846, 767	10/1/2006	CHEN		
	Subclass 700MS	Subclass Date 700MS 10/1/2006		

SEARCH N (INCLUDING SEAR))
	DATE	EXMR
EAST (search updated).	10/1/2006	CHEN